AGENT. DOCKET NO. SERIAL NO. -1449U.S. DEPARTMENT OF COMMERCE ONX-117A 09/851,587 **APPLICANT** LIST OF PRIOR ART CITED BY APPLICANT Murali Chaparala (Use several sheets if necessary) FILING DATE **GROUP** May 8, 2001 2862 U.S. PATENT DOCUMENTS **EXAMINER** DOCUMENT NAME CLASS SUBCLASS FILING DATE INITIAL NUMBER APPROPRIATE 6,359,741 3/12/2002 Bilotti et al. 455 90 6/22/1999 5,629,918 5/13/1997 Ho et al. 369 112 1/20/1995 6,528,887 3/4/2003 Daneman et al. 257 774 3/1/2001 2002/0167307 11/14/2002 Chaparala et al. 207.13 324 5/11/2001 FOREIGN PATENT DOCUMENTS DOCUMENT DATE COUNTRY CLASS **SUBCLASS** TRANSLATION NUMBER YES NO OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.) Eyre et al. "MEMS Magnetic Sensor in Standard CMOS, Science Closure and Enabling Technologies for Constellation Class" [online], [retrieved on 2002-03-17]. Retrieved from the Internet < URL: http:sprg.ssl.Berkeley.edu/ConstellationClassMissions/eyre.pdf> Miller R. et al. "A Megnetically Actuated MEMS Scanning Mirror", International Society for Optical В Engineering, Vol. 2687 (March 1996), pp. 47-52. **EXAMINER** DATE CONSIDERED 115105 * EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if

not in conformance and not considered. Include copy of this form with next communication to applicant.



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

TRADE CENTRAL Vorsion v18 Stylesheet Version v18.0

> Title of Invention

Magnetic Position Detector For Micromachined Optical Element

Application Number:

09/851587

Confirmation Number:

2627

First Named Applicant:

Murali Chaparala

Attorney Docket Number: ONX-117A

Art Unit:

2862

Examiner:

Subhash A Zaveri

Search string:

(6215318 or 20030117027).pn.

Certification: This Information Disclosure Statement was submitted under the following conditions, which satisfies the requirement under 37 CFR 1.97(e). The filer certified:

That no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of the information disclosure statement.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No. Patent No.		Date	Patentee	Kind	Class	Subclass	
300	1	6215318	2001-04-10	Schoefthaler et al.	A1	324	658	

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No. Pub. No.		Date	Applicant	Kind	Class	Subclass	
86	1	20030117027	2003-06-26	Rybnicek et al.	A1	310	28	

Signature Jagnata

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LIST OF PRIOR ART CITED BY APPLICANT (Use several sheets if necessary)					ATTY. DOCKET NO. ONX-117A			SERIAL NO. 09/851,587				
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